

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: OKAJIMA, et al.

Serial No.: 10/581,557

Filed: June 2, 2006

Title: Method for Processing Substrate, Apparatus for Processing Substrate, Method for Conveying Substrate and Mechanism for Conveying Substrate

Art Unit: 3724

Examiner: Peterson, K.

Conf. No.: 6205

**AMENDMENT**

Mail Stop: Amendment (No Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 21, 2009

Sir:

This is in response to the Office Action mailed October 16, 2008, in connection with the above-identified application. The amendments are listed below and set forth on the following pages.

Amendments to the Specification;

Amendments to the Claims;

Amendments to the Drawings; and

Remarks are included following the amendments.